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## BIB DATA SHEET

CONFIRMATION NO. 1790

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/564,750	01/17/2006	430	1792	Q92709		
<b>RULE</b>						
<b>APPLICANTS</b> Masahiko Ishida, Tokyo, JAPAN; Hiroo Hongo, Tokyo, JAPAN; Jun-ichi Fujita, Tokyo, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/10301 07/20/2004 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-276482 07/18/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 02/01/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b>	<b>SHEETS DRAWINGS</b>	<b>TOTAL CLAIMS</b>	<b>INDEPENDENT CLAIMS</b>
Verified and /FELISA CARLA HITESHEW/	Acknowledged	Initials	JAPAN	13	31	2
<b>ADDRESS</b> SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES						
<b>TITLE</b> Method for fixing metal particles and method for manufacturing substrate containing metal particles, method for manufacturing substrate containing carbon nanotube, and method for manufacturing substrate containing semiconductor-crystalline rod, employing thereof						
<b>FILING FEE RECEIVED</b> 2660	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		